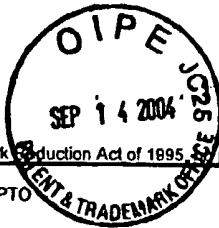


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Sheet 2

of 2

Application Number 09/994,867

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First Named Inventor SULESKI

Art Unit 1756

Examiner Name J. McPherson

Attorney Docket Number 280/075

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
JA	3.	Patent Abstracts of Japan, Vol. 011, No. 293 (P-619), 22 Sept. 1987, & JP 62 088149 A (Hitachi Ltd.)	
JA	4.	NUSSBAUM, et al., *, Proceedings of the SPIE, Vol. 3226, pp. 32-43, (1997)	
		*Entitled: "Refractive and diffractive elements for micro-optical systems"	
JA	5.	FERSTL, et al., **, Ann. Report 1998, Heinrich-Hertz-Institute fur Nachrichtentechnik, 109-112, 1999	
		** Entitled: "Commercial Fabrication of Micro-Structures and Micro-Optical Elements for Research..."	
JA	6.	STERN, ***, Microelectronic Engineering, Vol. 34, No. 3-4, pp. 299-319, (1 December 1997)	
		*** Entitled: "Pattern transfer for diffractive and refractive microoptics"	
JA	7.	MONTAMEDI, et al., ****, Opt.Eng. 36(5): 1282-1297 (May 1997)	
		****Entitled: "Micro-opto-electro-mechanical devices and on-chip optical processing"	
JA	8.	WU, et al, "Micromechanical Photonic Integrated...", IEICE Trans. Electron, Vol. E83C:903-911 6/2000	

Examiner Signature	John McPherson	Date Considered	10/6/04
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